

PATENT  
254/138  
P97-0041US3

APU  
3/14/01  
H5B  
600/k



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: ) Group Art Unit: 3652  
)  
Raymon F. Thompson et al ) Examiner: Keenan, J.  
)  
Serial No.: 09/575,551 )  
)  
Filed: 5/22/00 )  
)  
For: SEMICONDUCTOR PROCESSING )  
SYSTEM WITH WAFER )  
CONTAINER DOCKING AND )  
LOADING STATIONS )

AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In reply to the Office Action mailed November 9, 2000, please amend the above-identified application as follows:

In the claims, please cancel claims 58-61 and 63.

CERTIFICATE OF MAILING  
(37 C.F.R. §1.8a)

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

February 27, 2001  
Date of Deposit

Laura Murphy  
Name of Person Mailing Paper

Signature of Person Mailing Paper